



PATENT
D-95013A

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

AHMAD (NMI) WALEH ET AL

Serial No.: 09/141,443

Group Art Unit: 1746

Filed: August 27, 1998

Examiner: A. Markoff

For: METHOD OF REMOVING ORGANIC
MATERIALS FROM SUBSTRATES

Assistant Commissioner for Patents

Washington, D.C. 20231

AMENDMENT

Sir:

This is in response to the Office Action dated May 9, 2000, rejecting Claims 3-23, and 25-30 in the above-identified patent application. Applicants have previously submitted a Change of Address for the undersigned attorney. A copy of that Change of Address is included herewith. Please direct all further communications regarding this application to the undersigned at his new address.

Please amend the application as follows:

IN THE SPECIFICATION:

Page 1, line 29, delete "include" and insert in place thereof --are included--; after "example," insert --in--.

Page 2, line 12, after "photoresists" insert --from substrates--;

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